

ISSUE CLASSIFICATION	
Class	Subclass

PATENT NUMBER

**U.S. UTILITY Patent Application**

**O.I.P.E.**

**PATENT DATE**

SCANNED

PA Am

APPLICATION NO. 09/866665	CONT/PRIOR F	CLASS 136	SUBCLASS 243	ART UNIT 1755 1753	EXAMINER <del>XXXXXXXXXX</del>
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## APPLICANTS

**TITLE**

Silicon-type thin-film formation process, silicon-type thin film,  
and photovoltaic device

PTD-2040  
12/89**ISSUING CLASSIFICATION**

ORIGINAL				CROSS REFERENCE(S)					
CLASS		SUBCLASS		CLASS	SUBCLASS (ONE SUBCLASS PER BLOCK)				
INTERNATIONAL CLASSIFICATION									

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<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>	<b>DRAWINGS</b>			<b>CLAIMS ALLOWED</b>	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
<input type="checkbox"/> The term of this patent subsequent to _____ (date) has been disclaimed.	_____ (Assistant Examiner) (Date)			<b>NOTICE OF ALLOWANCE MAILED</b>	
<input type="checkbox"/> The term of this patent shall not extend beyond the expiration date of U.S Patent. No. _____ _____ _____	_____ (Primary Examiner) (Date)			<b>ISSUE FEE</b>	
				Amount Due	Date Paid
<input type="checkbox"/> The terminal _____ months of this patent have been disclaimed.	_____ (Legal Instruments Examiner) (Date)			<b>ISSUE BATCH NUMBER</b>	
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